



**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re application of: Patton et al.

Atty Dkt No.: NOVLP016C1/NVLS-000403C1

Application No.: 10/693,223

Examiner: Nguyen, H.

Filed: October 24, 2003

Group: 2812

Title: SEQUENTIAL STATION TOOL FOR  
WET PROCESSING OF  
SEMICONDUCTOR WAFERS

**CERTIFICATE OF MAILING**

I hereby certify that this correspondence is being deposited with the U.S. Postal Service with sufficient postage as first-class mail on August 31, 2005 in an envelope addressed to the Commissioner for Patents, P.O. Box 1450 Alexandria, VA 22313-1450.

Signed: \_\_\_\_\_

Tara Hayden

**RESPONSE TO OFFICE ACTION**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Dear Sir:

In response to the Final Office Action dated May 3, 2005, please amend the above-identified application as follows:

**Amendments to the Claims** appear in the Listing of Claims that begins on page 2 of this paper.

**Remarks/Arguments** begin on page 4 of this paper.